

Kokusai
QUIXACE MT-SiOCN Furnace
SN T2DC6-20571-1
Vintage 17-09-2020

QUIXACEI®- $\Pi$  is a KOKUSAI ELECTRIC's latest platform for batch thermal processing of 300mm wafers. QUIXACEI®- $\Pi$  offers high throughput by utilizing advanced technologies in such areas as temperature control, wafer handling automation, reactor purging.

### **Features**

- •Achieved high productivity: Improved 1.25times(\*) larger lot processing in a time (\* Compared with previous model)
- Capable of conformal films into deep trench
- •Realized high accurate, high quality film deposition in low temperature
- Health check function (Option)







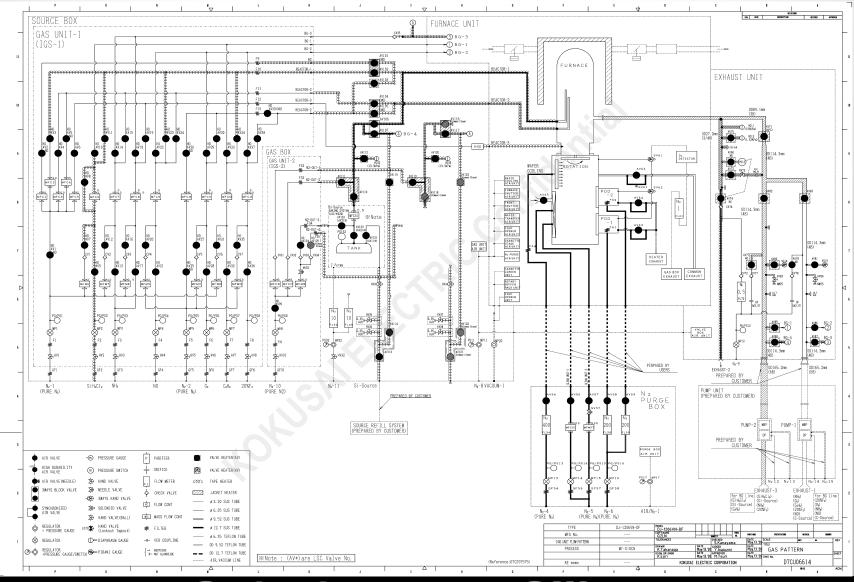




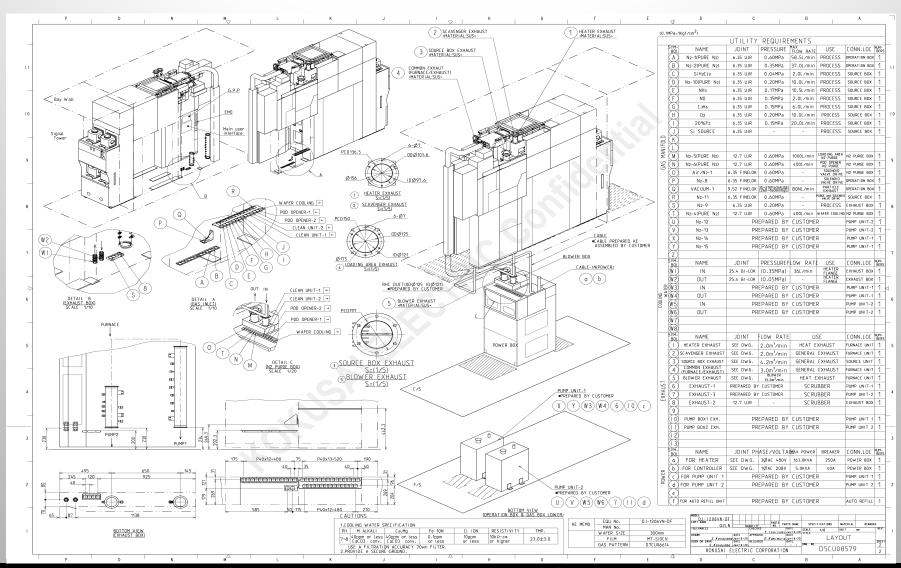












## **Solutions on Silicon BV**

Your service partner for LAM Research Equipment

## Equipment Support

PM, CM, Trouble shooting, Upgrading, Training and Onsite Service Contracts

### Process Support

Process design, Improvement, Fab-to-Fab Transfer and Integration

#### Refurbishment

From custom to complete refurbishment

### Relocation

Auditing, Fingerprinting, Decommissioning, Installation, Acceptance

### Materials

Supplier of first class second source materials

